



Patent
Attorney's Docket No. 007413-056

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Oliver KIENZLE et al.

Application No.: 10/614,825

Filed: July 9, 2003

For: METHOD FOR THE ELECTRON-
MICROSCOPIC OBSERVATION OF A
SEMICONDUCTOR ARRANGEMENT
AND APPARATUS THEREFOR

)
) Group Art Unit: 2621

)
) Examiner: Unassigned

)
) Confirmation No.: 8138

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents
Office of Initial Patent Examination
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Sir:

Enclosed is a copy of the Official Filing Receipt marked in red to show correction that is needed. The correction is as follows.

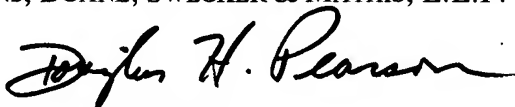
In the Applicant(s) section please delete "Ingo Muller, Aalen, GERMANY" and insert --Ingo Müller, Aalen, GERMANY--.

Issuance of a corrected Official Filing Receipt is respectfully requested.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date: December 31, 2003

By: 
Douglas H. Pearson
Registration No. 47,851

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/614,825	07/09/2003	2621	852	007413-056	9	21	4

CONFIRMATION NO. 8138

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OC000000010985242

Date Mailed: 10/06/2003

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Applicant(s)

Oliver Kienzle, Aalen, GERMANY;
Rainer Knippelmeyer, Aalen, GERMANY;
~~Ingo Muller, Aalen, GERMANY;~~

INGO MÜLLER, Aalen, GERMANY

Assignment For Published Patent Application

LEO Elektronenmikroskopie GmbH, Oberkochen, GERMANY;

Domestic Priority data as claimed by applicant

Foreign Applications

GERMANY 102 30 929.9 07/09/2002

If Required, Foreign Filing License Granted: 10/03/2003

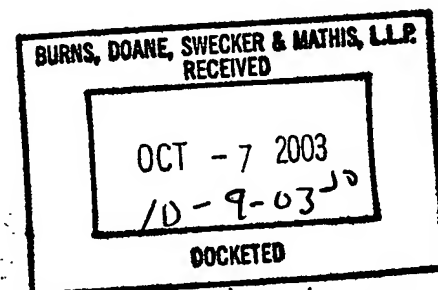
Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Method for the electron-microscopic observation of a semiconductor arrangement and apparatus



Dietl Glaser
007413-056
JWP/DHP

10/17/03

therefor

Preliminary Class

382

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